

TCAD Analysis of Silicon-Germanium (SiGe) based Back-Contact Back-Junction (BC-BJ) solar cell as an alternative for silicon based cells

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ABSTRACT

In this work, an ultra-thin, Back-Contact Back-Junction (BC-BJ) Silicon-Germanium (SiGe) solar cell device structure called BC-BJ SiGe solar cell has been proposed, which shows enhanced photovoltaic properties, External Quantum Efficiency (EQE) > 76% in the spectrum range of 400-700 nm wavelength have been achieved. Results further, reveal that proposed device is less affected by carrier recombination, resulting in 13.5 % power conversion efficiency (PCE). Also we obtained the impact of material thickness on device parameters and we found that the 5 μ m thick SiGe cell is as efficient as 10 μ m thick silicon cell. The PCE of 5 μ m thick SiGe cell and 10 μ m thick silicon cell was 11.3% and 11.8%, respectively. It indicates that the proposed device significantly save the material cost over the silicon cell. All the simulations have been done using DEVEDIT and ATLAS device simulator.

Keywords: Efficiency, Recombination, Silicon-Germanim, Solar cell

1 INTRODUCTION

Crystalline silicon is the largest component of the solar photovoltaic (PV) cells. Over 80% installed solar PV in 2011 used silicon as their largest material. Silicon is widely used material for PV due to its reliability, abundance, and mature fabrication process. In Silicon PV technology, absorption coefficient of Silicon is small, to absorb enough of the solar cell spectrum. The thickness of conventional silicon cell is typically more than 100 μ m, in order to absorb the solar spectrum. Now since, thickness is large, in order to collect light generated carrier, minority carrier lifetime must be high enough and the recombination coefficient should be low. This requirement of large volume and high quality silicon significantly increases the module cost. In order to make photovoltaic system feasible at large scale, it should be cost effective, with module cost to be < \$0.5/W [1]. In this paper, we proposed SiGe as an alternative to silicon solar cell, due to its higher minority carrier lifetime and lower recombination coefficient. Reducing the thickness of PV materials used in solar cell production is a major goal of

solar cell industry, due to its fruitful contribution to the overall cost of a PV system. However, thin silicon cells are not effective, due to severe Auger recombination and increased surface to volume ratio [2].

One promising high-efficiency solar cell concept is the back-contact back- junction solar cell [3, 4] having both, junction and the electrodes at back side of the device. Now, since the junction and contacts are at the back side, Front surface can be designed for optimum optical performance [5].

Here, we proposed novel 10 μ m thick crystalline SiGe back-contact back-junction solar cell, which overcomes the critical problems of thin devices: Auger and surface recombination etc. Further, we have obtained the impact of material thickness on photovoltaic parameters. In SiGe technology the electrical properties of silicon are modified with germanium. SiGe processing is simple because the physical and electrical properties of silicon and germanium are similar [6]. Also SiGe possesses higher mechanical strength, and suppresses the high intensity degradation of solar cell under illumination [7]. Optical absorption of SiGe can further be modified by varying Ge content [8, 9].

2 DEVICE STRUCTURE AND PHYSICAL MODELS

Silvaco ATLAS used to simulate the device optoelectronic characteristics. ATLAS is a device simulator capable of modeling the electrical, thermal, and optical characteristics of semiconductor devices.

In the simulation, we assume a two dimensional structure, BC-BJ solar cell as shown in Fig. 1. The Si_{0.9}Ge_{0.1} was used during the simulation, very small fraction of germanium is used. Because, if we increase the germanium content the bandgap of SiGe decreases [10] The substrate was N-type, with doping density of 3x10¹⁵ cm⁻³, whereas N+/P+ region has the doping density of 4x10²⁰ cm⁻³. The depth of P+ and N+ region was 3 μ m and 2.5 μ m, respectively, whereas the width was 40 μ m and 30 μ m, respectively. The Nitride (Si₃N₄) is used as anti-reflecting front surface passivation, and modeled as an optical layer with the thickness of 70 nm. The Oxide (SiO₂) is used as back surface passivation with thickness of 50nm.

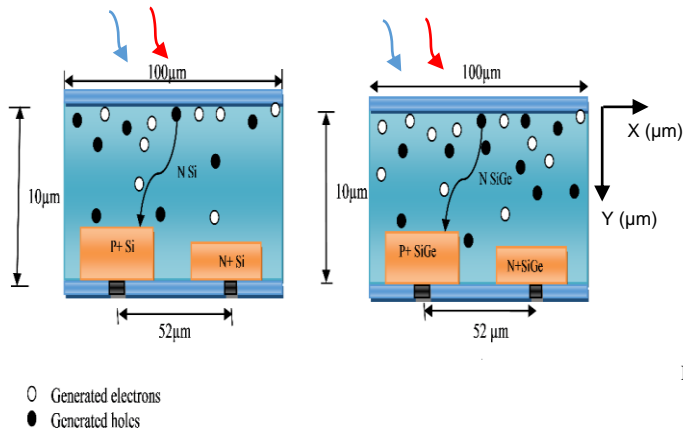


Fig.1. Simulated device: - 10µm thick BC-BJ solar cell: (a) Silicon (b) SiGe

To obtain the J-V curve under illumination, we used the standard AM1.5 solar spectrum, divided into 400 points. The models used in the simulation assume a concentration dependent mobility using default software values for electron and holes [11]. Shockley – Read-Hall and Auger recombination mechanisms were taking into account. Auger recombination was modeled with the default software values of Auger coefficient $2.8 \times 10^{-32} \text{ cm}^6 \text{ s}^{-1}$ for electrons and $9.9 \times 10^{-32} \text{ cm}^6 \text{ s}^{-1}$ for holes, in case of silicon, whereas $9.9 \times 10^{-31} \text{ cm}^6 \text{ s}^{-1}$ for electrons and $1.8 \times 10^{-31} \text{ cm}^6 \text{ s}^{-1}$ for holes were used, in case of SiGe. The minority carrier lifetime of 10^{-6} s and 10^{-5} s has been used for silicon and SiGe, respectively. The Poisson equation together with the continuity equation for electrons and holes are solved simultaneously by the software to obtain the J-V characteristics.

3 SIMULATION RESULTS

Figure 2 shows the contour plot of recombination rate. The magnitude of recombination rate in silicon cell is in the order of ($10^{20} / \text{cm}^3 \text{ s}$), whereas in proposed device it is ($10^{18} / \text{cm}^3 \text{ s}$).

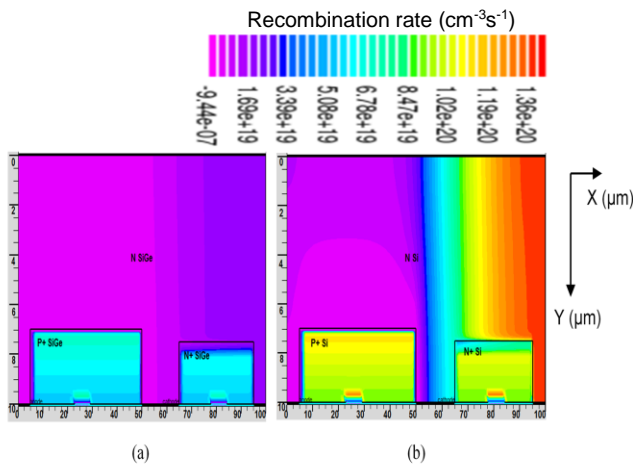


Fig. 2. Recombination rate contour (logarithmic plot): (a) 10µm thick BC-BJ SiGe solar cell (b) 10µm thick BC-BJ Si solar cell.

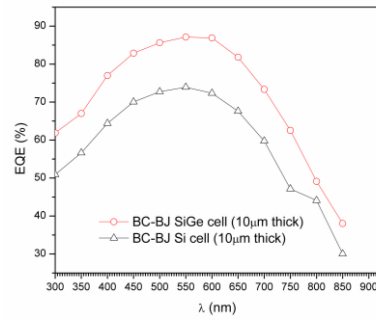


Fig. 3. Comparison of External Quantum Efficiency (EQE)

At the interface, recombination rate is higher in right side of the devices because collection probability of minority carriers (hole) is decreases. The lower recombination is observed in novel device because minority carrier lifetime is higher compared to silicon cell. In back contact design, most of the carriers are generated near the front surface, while the junction is far at the back surface. Lower recombination ensure higher carrier collection efficiency.

Also, the EQE of the proposed device is higher than silicon cell as shown in Fig 3. The proposed device shows $\text{EQE} > 76\%$ in the spectrum range of 400-700 nm wavelength whereas in silicon cell, $\text{EQE} > 60\%$ was obtained. The proposed device shows 26% higher EQE compared to silicon cell, due to the presence of Ge. Since, the no. of free electrons in the germanium is higher than the silicon at given temperature, which results in higher conductivity of Ge.

Further, we have obtained the impact of device thickness on photovoltaic parameters. We have decreased the device dimension to half the initial dimensions, discussed earlier, keeping the aspect ratio (Width/Depth) of P+ and N+ region fixed 1/15 and 1/12, respectively. The length of the pitch becomes 26µm. The electrical parameters of 10µm thick devices and 5µm thick devices are plotted in Fig 4. Fig. 4(a&d), shows the current density-voltage (J-V) curve and PCE bar for different devices, when thickness of silicon cell decreased from 10µm to 5µm, change in short circuit current density J_{SC} and PCE was 26.6% and 26.2%, respectively, whereas for SiGe it was 17.7% and 16.3%, respectively. It shows that proposed device is less affected by the thickness variation compared to the conventional silicon cell. Also Fig. 4(b&d) shows that the maximum output power density (P_M) of 10µm thick silicon cell and 5µm thick SiGe cell was approximately same, 11.8 mW/cm^2 in 10µm thick silicon cell and 11.3 mW/cm^2 in 5µm thick SiGe cell, respectively. Also, open circuit voltage (V_{OC}) can be obtained by taking the intercept to x-axis from the sharp minima, shown in Fig. 4c. Proposed device shows superior photovoltaic properties comparing to conventional silicon cell due to lower recombination [12]. Detailed comparisons of electrical parameters are shown in Table 1. Table 1, shows that the performance of 5µm thick SiGe was approximately equal to the 10µm thick silicon cell, indicating that the proposed device significantly saves the material cost over silicon cell.

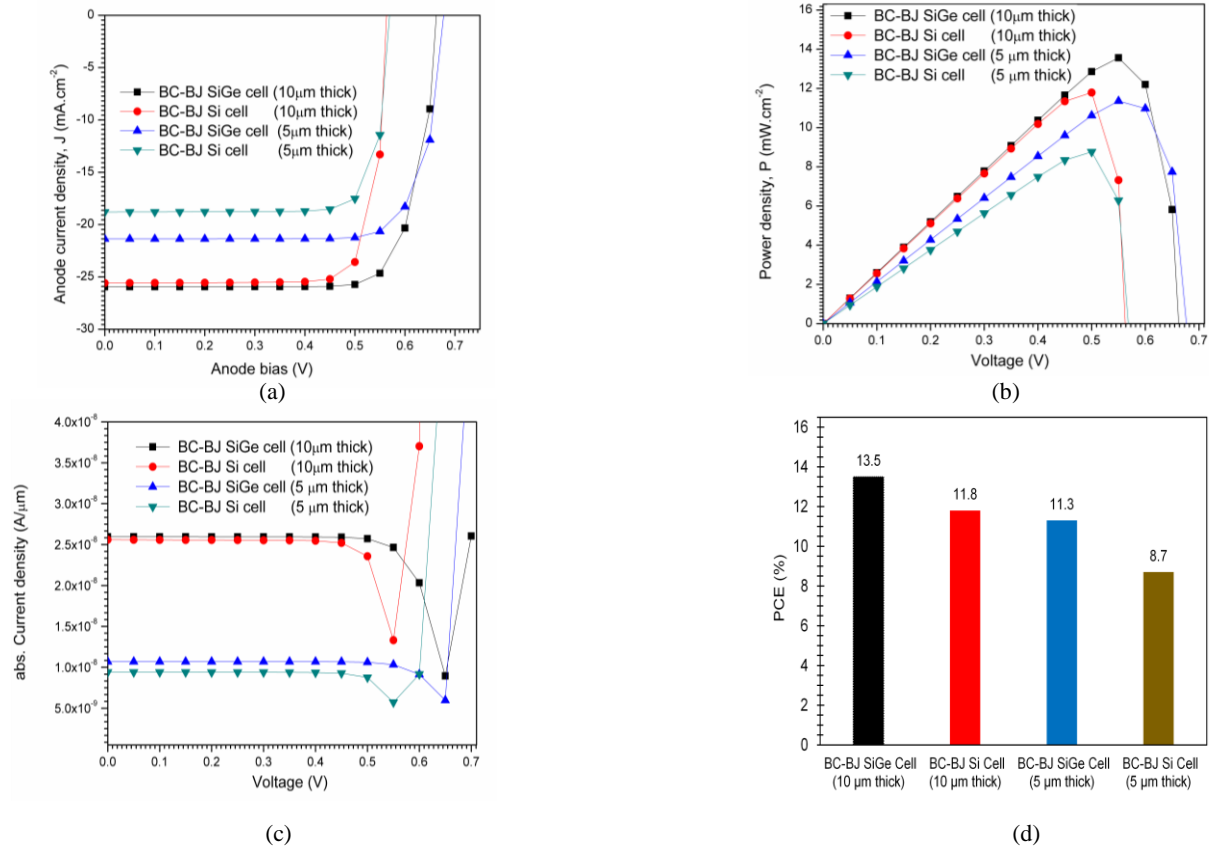


Fig.4. Comparisons of electrical characteristics of different devices: (a) J-V, (b) Power density-voltage, (c) Abs.current density-voltage (d) PCE.

Table1. Detailed comparisons of electrical parameters

Device	Voc (V)	Jsc (mAcm ⁻²)	FF (%)	PCE (%)
Silicon cell (10 μm thick)	0.563	25.6	81.8	11.8
SiGe cell (10 μm thick)	0.663	25.9	78.8	13.5
Silicon cell (5 μm thick)	0.569	18.8	81.9	8.7
SiGe cell (5 μm thick)	0.677	21.3	78.4	11.3

FF-fill factor, PCE- power conversion Efficiency.

4 CONCLUSION

In this work, we proposed a novel 10 μm thick BC-BJ SiGe Solar cell design, as a cost-effective solution for energy efficient applications. The work analyse and compares the optical and electrical characteristics of proposed design using Silvaco Atlas device simulator.

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